



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

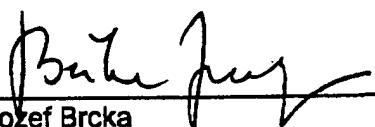
Serial No.: 10/080,496
Filed: February 22, 2002
Applicant: Jozef Brcka
Art Unit: 1763
Examiner: L.L. Alejandro Mulero
Title: MODIFIED TRANSFER FUNCTION DEPOSITION BAFFLES
AND HIGH DENSITY PLASMA IGNITION THEREWITH IN
SEMICONDUCTOR PROCESSING
Attorney Docket: TAZ-213

DECLARATION UNDER 37 C.F.R. §1.132

I, Jozef Brcka, am the sole inventor and applicant on the present application. I am also the sole inventor and applicant on U.S. Patent No. 6,523,493. Any invention disclosed but not claimed in U.S. Patent No. 6,523,493 was by me or derived from me.

I hereby declare that all statements made herein of our own knowledge are true and that all statements made on information and belief are believed to be true; and further that these statements were made with the knowledge that willful false statements and the like so made are punishable by fine or imprisonment or both, under Section 1001 of Title 18 of the United States Code and that such willful false statements may jeopardize the validity of the subject application or any patent issued thereon.

May 10, 2004
Date


Jozef Brcka